

Electronic Patent Application Fee Transmittal

Application Number:	10828596			
Filing Date:	21-Apr-2004			
Title of Invention:	Methods of forming metal thin films, lanthanum oxide films, and high dielectric films for semiconductor devices using atomic layer deposition			
First Named Inventor/Applicant Name:	Ki-yeon Park			
Filer:	Shawna Cannon Lemon/Laneisha Hayes			
Attorney Docket Number:	5649-1286			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				810